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U.S. PATENT DOCUMENTS

*Examiner (Initial)		Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
	AA						
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FOREIGN PATENT DOCUMENTS

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						Yes
	AM					
	AN					
	AO					
	AP					
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

TN	AR	Pierson, Handbook of Chemical Vapor Deposition, Noyes Publications: New Jersey, 1992, pp. 232-233.				
	AS					
	AT					

EXAMINER

John T. Nauert

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